

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | |
|--|-----------------------------------|
| In re the Patent Application of: | |
| Changsoo Kwak | Examiner: Michael Patrick Stafira |
| Serial No. 10/731,557 | Art Unit: 2877 |
| Filed: December 8, 2003 | Confirmation No. 5059 |
| For: APPARATUS FOR SHIFTING REFERENCE DISTANCE OF LASER DISPLACEMENT SENSOR | |

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Dear Commissioner:

In response to the Notice of Non-Compliant Amendment mailed February 26, 2007, regarding the above- referenced application, Applicant respectfully requests entry of the amendment set forth below and consideration of the remarks that follow.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.

Figures (2) are attached following page 7 of this paper.